

	Type	L #	Hits	Search Text
1	BRS	L1	6686	(remove or removing or removed or removal or treat or treating or treated or treatment or eliminate or eliminated or eliminating or elimination or clean or cleaning or cleaned or cleaner or cleanse or cleansing or cleansed or cleanser) adj10 (contaminant or soil or soiling or residue or residue or residual or particle or particulate or impurity or foreign adj3 matter or foreign adj3 material or dirt) adj10 (chuck or vacuum adj4 chuck or spindle adj4 chuck or wafer or semiconductor adj4 (boat or cassette or holder or support or clamp ))
2	BRS	L2	497801	(chuck or vacuum adj4 chuck or spindle adj4 chuck or wafer or semiconductor adj4 (boat or cassette or holder or support or clamp ))
3	BRS	L3	8	12 same (homopolymer adj4 acetal)
4	BRS	L4	165805	(chuck or vacuum adj4 chuck or spindle adj4 chuck or ((wafer or semiconductor) adj4 (boat or cassette or holder or support or clamp )))
5	BRS	L5	2	14 same (homopolymer adj4 acetal)
6	BRS	L6	3	(chuck or vacuum adj4 chuck or spindle adj4 chuck) and (homopolymer adj4 acetal)

	DBs	Time Stamp	Comments	Error Definition
1	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT	2004/12/16 10:43		
2	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT	2004/12/16 10:44		
3	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT	2004/12/16 10:45		
4	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT	2004/12/16 10:45		
5	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT	2004/12/16 10:45		
6	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT	2004/12/16 10:48		

	Type	L #	Hits	Search Text
7	BRS	L7	44087	((wafer or semiconductor) adj4 (boat or cassette or holder or support or clamp ))
8	BRS	L8	12	17 same (homopolymer adj4 acetal or acetal)
9	BRS	L10	53	(chuck or vacuum adj4 chuck or spindle adj4 chuck) same (homopolymer adj4 acetal or acetal or acetal adj4 homopolymer)
10	BRS	L9	12	17 same (homopolymer adj4 acetal or acetal or acetal adj4 homopolymer)